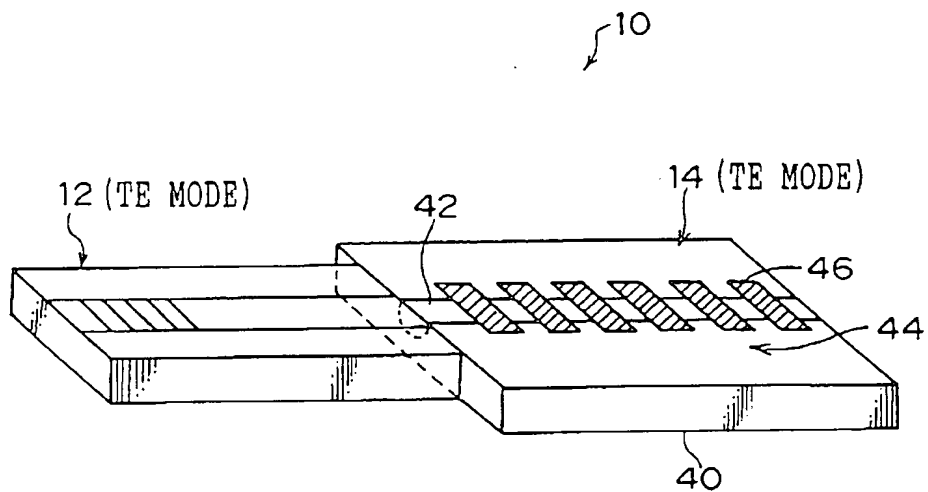


F I G. 1



BEAM EXITING PATTERN  
OF SEMICONDUCTOR LASER

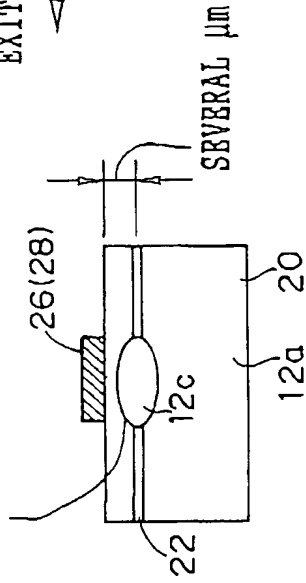


FIG. 2 A

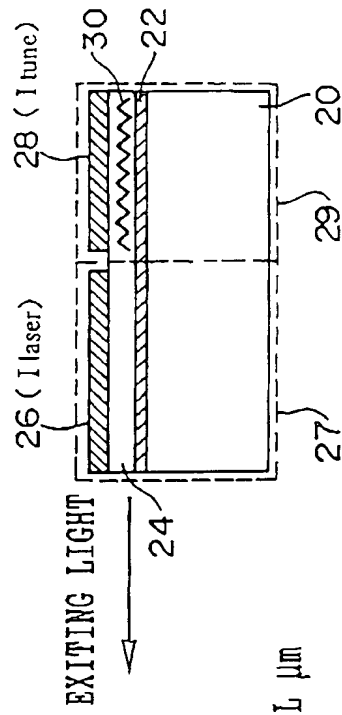


FIG. 2 B

FIG. 3

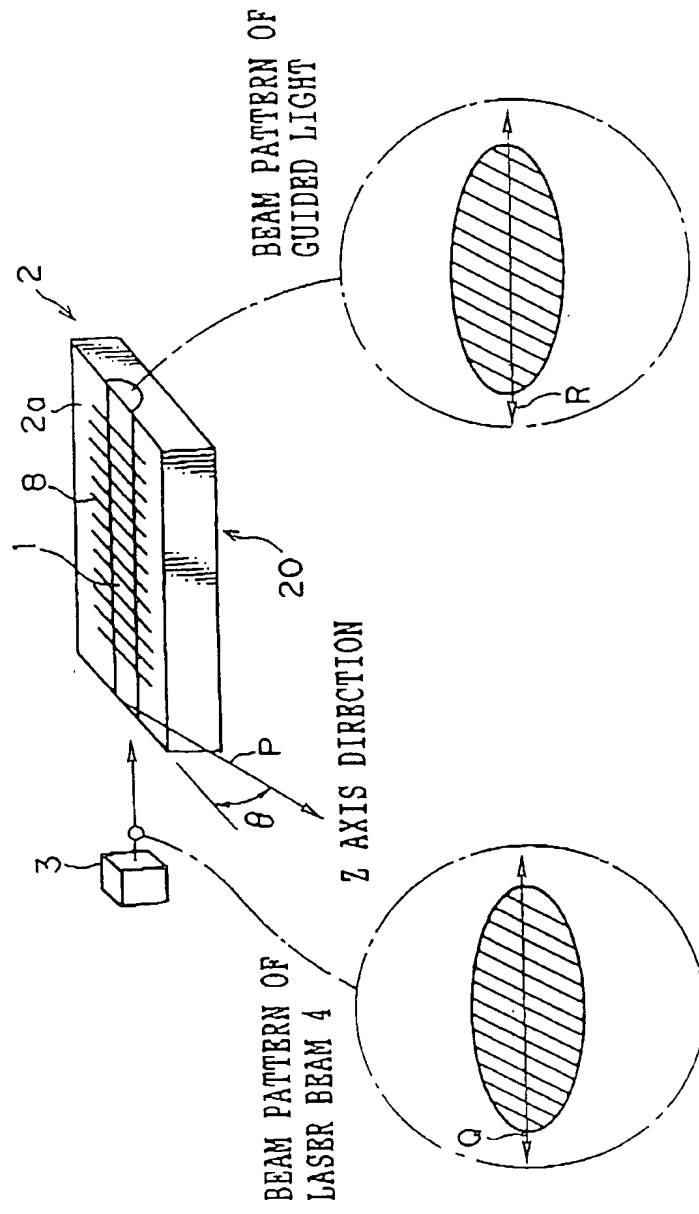
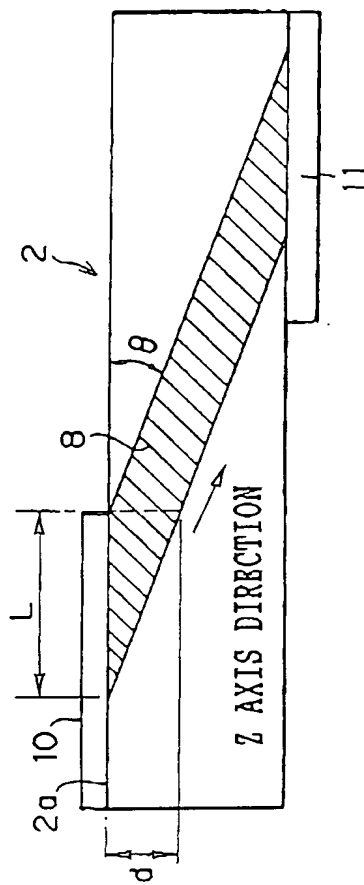
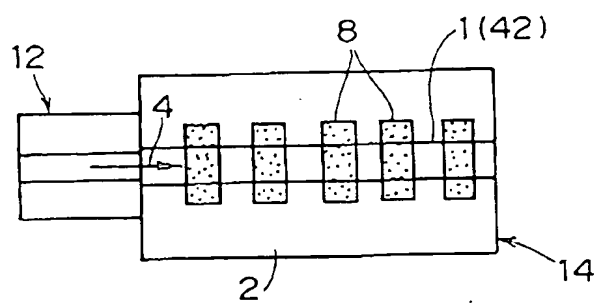


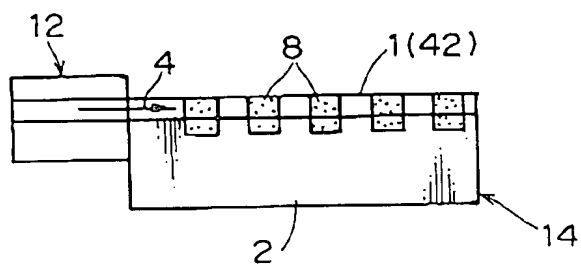
FIG. 4



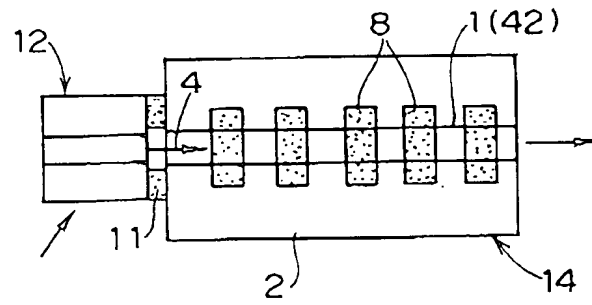
F I G. 5 A



F I G. 5 B



F I G. 6 A



F I G. 6 B

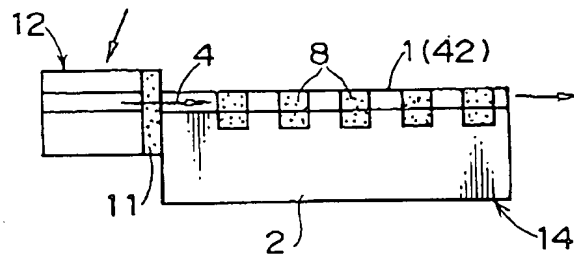
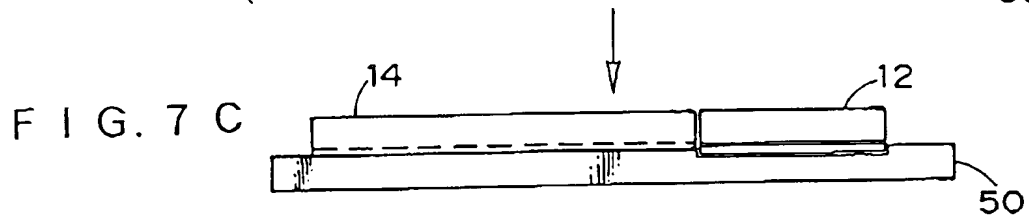
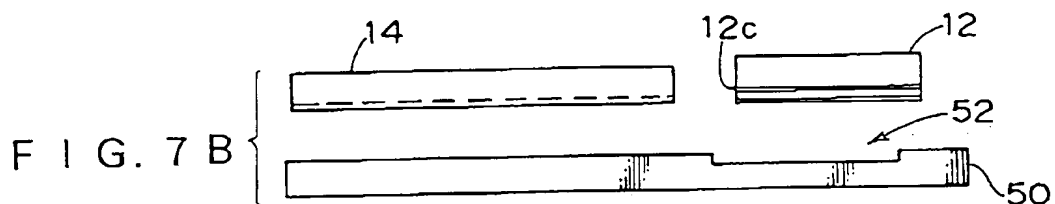
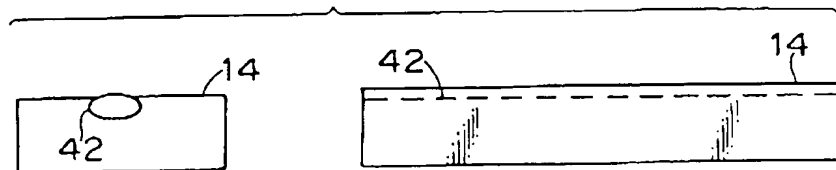
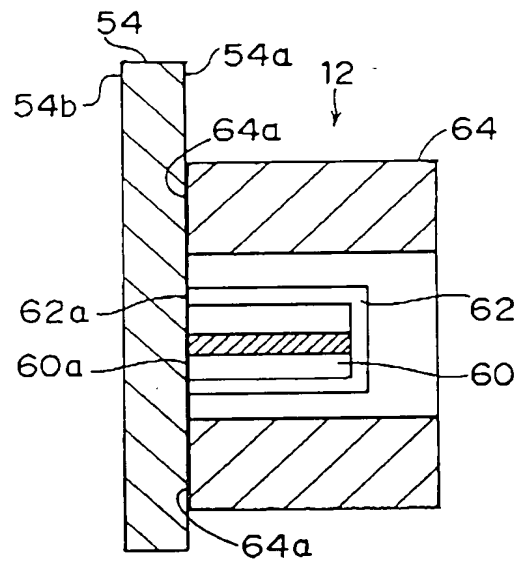


FIG. 7 A



F I G. 8 A



F I G. 8 B

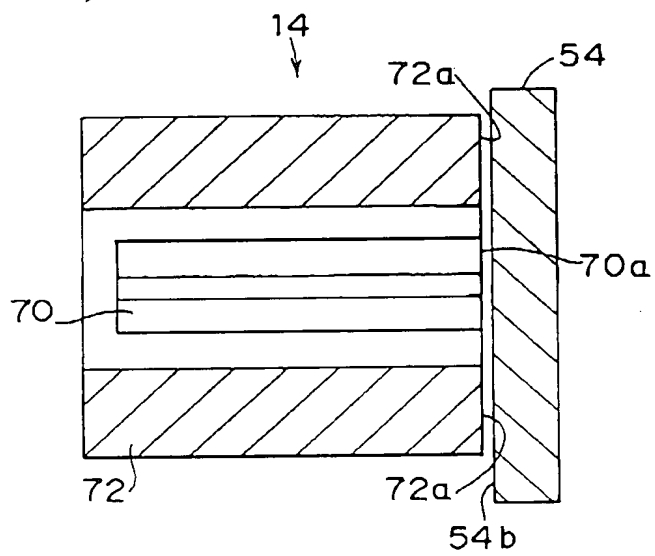




FIG. 9 A

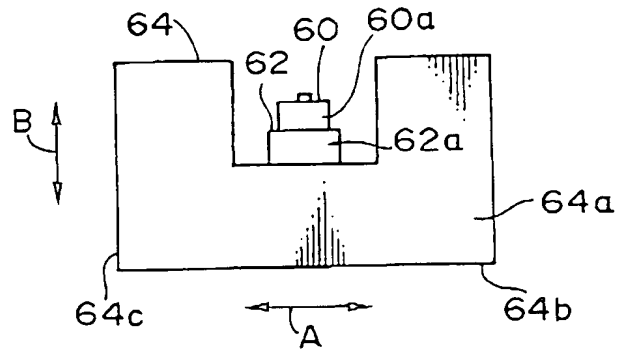
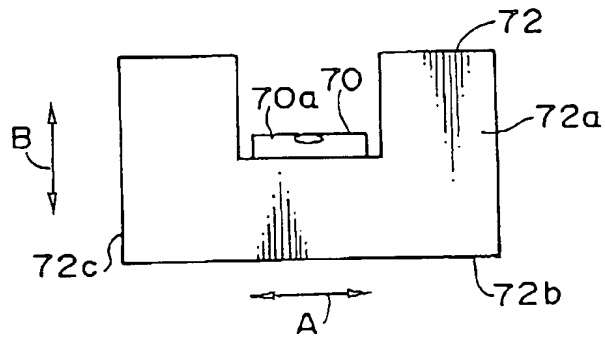
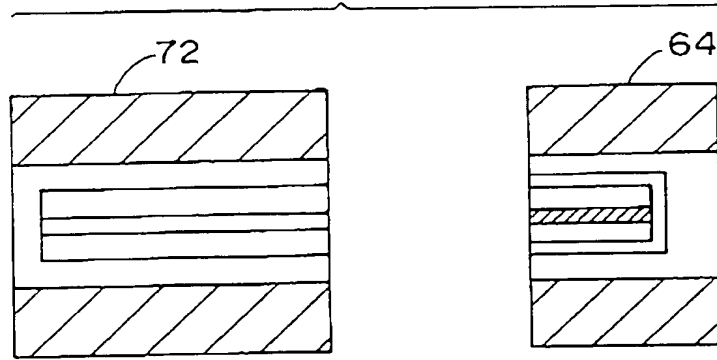


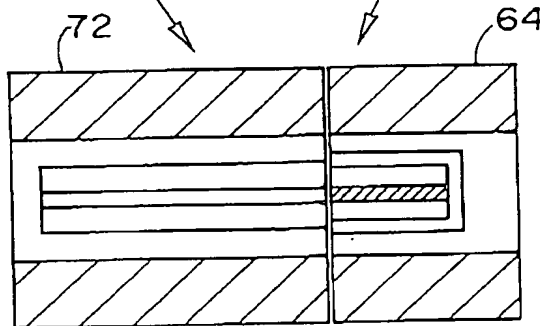
FIG. 9 B



F I G . 1 0 A



F I G . 1 0 B



F I G. 1 1

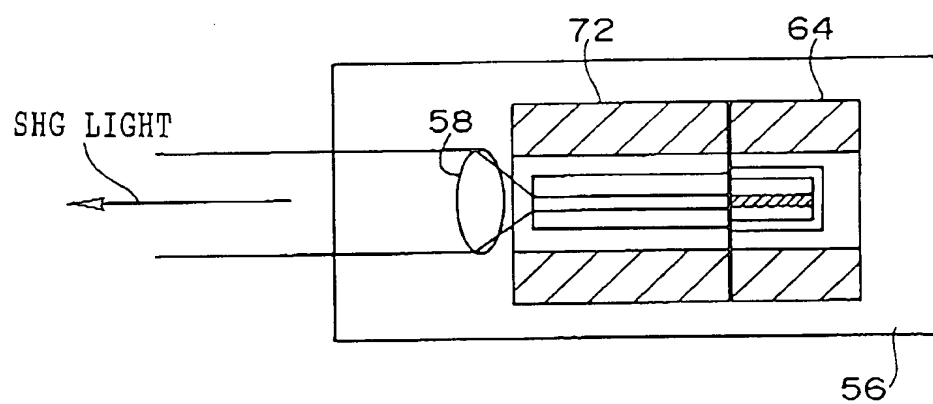


FIG. 12

